



In re patent application of
Basanth Jagannathan, et al.

Docket No.: 00750455AA

Serial No.: 09/843,783

Group Art Unit: 2823

Filed: April 30, 2001

Examiner: William Coleman

**For: METHOD TO INCREASE CARBON AND BORON DOPING
CONCENTRATION IN Si AND SiGe FILMS**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

**PETITION AND FEE FOR EXTENSION OF TIME
UNDER 37 C.F.R. 1.136**

Sir:

Applicant hereby petitions for a one-month extension of time to respond to the Office Action mailed on August 18, 2003 and to the Advisory Action mailed on December 10, 2003. Please charge the amount of \$110.00 (37 C.F.R. 1.17(a)(1)) to cover the extension fee, charge any deficiencies in payment and credit any overpayment to International's Business Machines Corporation's deposit account no. 09-0458.

Respectfully submitted,

Andrew M. Calderon
Reg. No. 38,093

McGuire Woods LLP
1750 Tysons Boulevard, Suite 1800
McLean, VA 22102
(703)712-5000

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